

# Saravana Prakash Natarajan

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## PROFILE

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Doctoral candidate with 7 years of laboratory experience, specializing in design, fabrication, measurement and modeling of planar and MEMS based RF and microwave circuits, sensors and antennas

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## EDUCATION

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<b>Doctor of Philosophy</b> <i>University of South Florida</i> Dissertation: Three Dimensional Micro Coaxial Transmission Line based Circuits and Applications Advisor: Prof. Thomas M. Weller	Dec.15, 2007
<b>Master of Science</b> <i>University of South Florida</i> Thesis: Microwave Characterization of Zinc Oxide Capacitors and Toroidal Inductors for Sensing Applications Advisor: Prof. Thomas M. Weller	2002
<b>Bachelor of Engineering (Electrical &amp; Electronics Engineering)</b> University of Madras, Chennai, India	2000

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## SKILLS

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- **Design and Analytical Skills**
    - RF/Microwave circuit design and modeling of **passive devices (100 MHz to 65 GHz)** and **RF sensors** using **Agilent's Advanced Design System (ADS)**
    - Electromagnetic simulation of **millimeter wave antennas** and **RF MEMS** devices using **Agilent Momentum (2.5-D)** and **Ansoft High frequency Structure Simulator (3-D)**
    - **Modeling**, Optimization, Statistical analysis and curve-fitting using MathCAD and Microsoft Excel
  - **MEMS Fabrication Processes**
    - Standard Class 1000 **cleanroom** procedures
    - **Lithography** – Quintel Mask Aligner, all common photoresists including sacrificial, planarizing polymers like PMMA, PMGI, polyimide, BCB etc
    - Plating - **Electroless and Electroplating** of copper and gold including through via metallization
    - Wet Chemistry – metal wet etches and wafer cleans
    - Bulk **Micromachining** – deep silicon etching using TMAH and KOH
    - **Thin Film** Deposition – thermal/E-beam evaporation and RF/DC sputtering of metals and dielectrics
    - Dry **Etching – Reactive ion** and plasma etching using the Plasmatherm 700 RIE system
    - Critical Point Dry – Tousimis Automatic Critical Point dryer
  - **Measurement and Characterization**
    - Millimeter Wave Measurements – **1-65 GHz measurements on-wafer** using Anritsu, **Agilent network analyzers** and a **Karl Suss semi-automatic probe station**
    - Familiarity with **NIST Multical** and **Cascade Wincal** software
    - **Impedance Measurements** – on-wafer impedance measurements using custom calibration techniques on the **Agilent 4287A LCR meter**
    - **Antenna Measurements** – radiation pattern measurements using coaxial detectors and on-wafer chip diodes in an **anechoic chamber** using DAMS automated measurement software
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## AWARDS AND ACHIEVEMENTS

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- Center for Wireless and Microwave Information Systems Tuition Assistance Fellowship (Doctoral Studies)
  - Published 13 papers in peer-reviewed conferences and journals and one pending patent
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- Best Student Paper Award - IEEE Wireless and Technology Conference, Dec. 2006
  - Student Poster Award – Third Place, Commercialization of Micro and Nano Systems conference, Aug. 2006
  - Best Student Poster Award - IEEE Wireless and Technology Conference, Apr. 2005
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## EXPERIENCE

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### Graduate Research Assistant

Sep. 2000-present

*Center for Wireless and Microwave Information Systems Tuition Assistance Fellowship*

*RF Microsystems Group, University of South Florida, Tampa, FL*

Perform research in RF MEMS, sensors and antennas to fulfill the requirements of the doctoral degree

- Trained and possess good working knowledge of various design and simulation software tools, fabrication and measurement equipment
- Involved in lab inventory management
- Training and mentoring undergraduate and graduate students
- Assisted in drafting proposals to federal funding agencies for procuring equipment and lab setup
- Attended and presented technical papers in several international conferences
- **Trouble Shooting/Maintenance/Training**
  - Performed managerial duties in the microwave characterization and the microfabrication laboratory including new user training
  - Developed procedures and trained several new students on fabrication and characterization equipment
  - *Performed maintenance/trouble shooting vacuum systems and fabrication equipment, inventory management, lab safety enforcement and hazardous waste disposal*

### Graduate Teaching Assistant

Aug. 2005-Dec 2005

*Dept. of Electrical Engineering, University of South Florida, Tampa, FL*

Assisted professor with the RF and Microwave Circuits- I course

- Conducted help sessions for homework and lab exercises
  - Graded homework and lab exercises
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## PUBLICATIONS

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### Patent

1. Contact-Less Fluid Conductivity Sensor Based on RF Detection, USF Ref. No. 05A017, filed 3/10/2005 (Pending)

### Papers/Presentations

1. **S.P. Natarajan** and T. M. Weller, "Micro-Coaxial Fed Millimeter-wave Slot Antenna", Accepted for publication at the Proceedings of *IEEE Radio and Wireless Conference, Jan. 2008*
  2. **S. P. Natarajan** and T.M. Weller, "Sensitivity Tunable Fluid Conductivity Sensor based on RF Phase Detection", *IEEE Sensors Journal*, vol. 7, no. 9, pp. 1300-1301, Sep. 2007.
  3. R. Heindl, H. Srikanth, S. Witanachchi, P. Mukherjee, A. Heim, and G. Matthews, S. Balachandran, **S. P. Natarajan**, and T.M. Weller, "Multifunctional ferrimagnetic-ferroelectric thin films for microwave applications", *Applied Physics Letters*, vol. 90, 252507, June 2007
  4. **S.P Natarajan** and T.M. Weller, "3-D Micro Coaxial Lines with Integrated MEM Capacitors" (Accepted for Publication in *IEEE Microwave and Wireless Components Letters*)
  5. **S. P. Natarajan** and T. M. Weller, "MEMS Based 3-D Micro Coaxial Transmission Lines", *Proc. IEEE Annual Wireless and Microwave Technology Conference*, Dec. 2006, pp. 1-3 (**Best Student Paper Award**)
  6. **S. P. Natarajan**, T. M. Weller, "MEMS based 3-D Micro Coaxial Structures", Student Poster presented at the *Commercialization of Micro and Nano Systems Conference*, Aug. 2006 (**Third Place Award**)
  7. **S.P. Natarajan**, T.M. Weller and A. M. Hoff, "Integrated Micro Coaxial Air-Lines with Perforations", *Proc. IEEE Intl. Microwave Symposium Digest*, Jun. 2006, pp. 424-427
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8. **S. P. Natarajan**, T. M. Weller, A. M. Hoff, "Air Core Micro-Coaxial Transmission Lines", Poster presented at *the IEEE Wireless and Technology Conference*, April 2005 (**Best Poster Award**)
  9. C. R. Trent, **S. P. Natarajan**, T. M. Weller and M. Smith, "A  $3 \times 3$ , K-Band CPW-fed, Aperture-Coupled Antenna Array for Radiometer Applications", *Proc. of the European Microwave Conference*, Oct. 2005, pp. 523-526
  10. **S.P. Natarajan**, T. M. Weller and D. P. Fries, "3-D PCB Toroidal Inductors for RF Applications", *Proc. of IMAPS 2005*
  11. D. Fries, H. Broadbent, G. Steimle, S. Ivanov, A. Cardenas-Valencia, J. Fu, M. Janowiak, T. M. Weller, **S. P. Natarajan**, L. Guerra, "PCBMEMS for environmental sensing systems" *Proc. of the 32nd Annual Conference of IEEE Industrial Electronics Society*, 2005.
  12. **Natarajan, S.P**, J. Huffman, T. M. Weller and D. P. Fries, "Contact-less toroidal fluid conductivity sensor based on RF detection" ,*Proc. of IEEE Sensors Conference*, 2004
  13. D. Fries, G. Steimle, H. Broadbent, S. Ivanov, **S. P. Natarajan**, A. M. Cardenas-Valencia, M. Janowiak, T.Weller, R. Benson and Fu, "Maskless Lithographic PCB/Laminate MEMS for Marine Sensing Systems", *Proc. 35<sup>th</sup> International Symposium on Microelectronics and Packaging society*, 2002

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## PROJECTS

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### Research Projects

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- **Micro Coaxial Transmission Line with Embedded MEM Devices**
    - Successfully fabricated and measured micro coaxial transmission line structures of 15, 25 and 40 $\Omega$  characteristic impedances with embedded variable MEM capacitors yielding a capacitance ratio of 6.5
    - Fabrication of an enhanced design with capacitance ratio  $> 50$  is in progress to realize an RF MEMS Shunt Capacitive Switch for 1 to 40 GHz operation with an isolation of 30 dB and insertion loss of 0.2 dB at 30 GHz
    - Notable features of the design include miniature size (470  $\mu\text{m}$  wide and 20  $\mu\text{m}$  height) and use of common MEMS fabrication techniques
    - Center conductor of the micro coaxial lines rests on a 10 $\mu\text{m}$  thick polyimide layer while the top lid(ground plane) is suspended in air
    - Wafer probing compatible due to ground-signal-ground probe pad termination
    - MEM device was realized using a fixed-fixed beam actuated by electrostatic force
  - **Micro Coax Fed 55-65 GHz Slot Antenna**
    - Return loss better than 15 dB, VSWR  $< 1.35$  dB was achieved, radiation pattern close to EM simulations was achieved
    - Slot formed on the top ground plane of the micro coaxial structure
    - Coaxial-fed, fully shielded, integrated design
    - Substantial size reduction achieved by folding the slot and the ground plane
  - **Impedance Measurement based Micro Coaxial Bacteria/Microbe Sensor**
    - Open ended Micro Coaxial probe used as an impedance sensor to detect bacteria suspended in saline
    - Successfully designed, fabricated and tested an open-ended micro coaxial probe (cross-sectional area – 75 $\times$ 20  $\mu\text{m}^2$ ) with an integrated microfluidic chamber and detected a minimum concentration of 100 CFU/ml of bacteria
    - Test samples as small as 15  $\mu\text{L}$
  - **RF Phase Detection based Fluid Conductivity Sensor**
    - Constructed and tested successfully in the 2-70 mS/cm conductivity range with a worst case error of 4%
    - Contact-less coil design makes it suitable for corrosive environments
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- PCB embedded thin toroidal coils specially designed for the sensor using full wave electromagnetic simulations
  - PCB based phase detection circuitry was designed and built to convert phase change to output voltage with sensitivity tunability
  - **Bulk Micromachined K-Band CPW-Fed 3 × 3 Patch Antenna Array**
    - Successfully fabricated and measured a 3 × 3 patch antenna array integrated with a CPW feed network on a silicon substrate
    - Antennas realized on bulk micromachined 200 μm deep cavity
    - Feed network was fabricated on a second substrate, aligned and bonded to the antenna array
  - **Pyroelectric Zinc Oxide Thin Film based Devices**
    - Optimization of RF sputtering parameters and post deposition techniques to obtain pyroelectric Zinc oxide (ZnO) thin films
    - MIM capacitors built out of ZnO dielectric for microwave characterization
    - Modeling of ZnO capacitors
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### Course Projects

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- **4 GHz Receiver Subsystem**
    - Designed, simulated and optimized components including a lumped element IF filter, distributed element LP filter and quadrature coupler using Agilent ADS and Momentum EM tools
    - Integrated components to build the receiver sub-system and optimized performance using a diode-mixer and input/output matching networks
    - Conversion loss of 10 dB was achieved
  - **Single Stage Low Noise Microwave Amplifier**
    - Designed for 1.5 GHz operation on a 31-mil thick FR4 substrate using lumped element matching/bias networks and a Motorola MRF947 BJT
    - Amplifier components optimized using Agilent ADS circuit and Momentum EM simulations
    - Achieved a gain of 10 dB, stability over 0.1 to 3.0 GHz, VSWR of 1.2 and a minimum noise figure of 2.4 at 1.5 GHz
  - **PIN Diode Measurements**
    - PIN diodes were characterized using I-V curves, forward current-resistance plots and S-parameter measurements at different bias voltages
    - Diodes are modeled for use in a 2 GHz attenuator circuit
  - **Term Papers**
    - Saravana P. Natarajan, "Reliability and Packaging Issues in a RF MEMS Switch", a detailed review of failure modes in a RF MEMS switch
    - Saravana P. Natarajan, "Towards an Accurate On-wafer Calibration Method", a review of the new and existing on-wafer calibration techniques used to improve on-wafer calibration accuracy
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### PROFESSIONAL MEMBERSHIPS

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- IEEE / Microwave Theory and Techniques Student Member
  - ETA Kappa Nu – USF chapter Member
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### REFERENCES

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- **Dr. Thomas M. Weller**, Professor, Dept. of Electrical Engineering, University of South Florida, E-mail: [weller@eng.usf.edu](mailto:weller@eng.usf.edu), Phone: 813-974-2440
- **Dr. Andrew M. Hoff**, Associate Professor, Dept. of Electrical Engineering, University of South Florida, E-mail: [hoff@eng.usf.edu](mailto:hoff@eng.usf.edu), Phone: 813-974-4958
- **Dr. Balaji Lakshminarayanan**, Research Associate, Dept of Electrical and Computer Engineering, University of California, San Diego, E-mail: [blakshmin@ece.ucsd.edu](mailto:blakshmin@ece.ucsd.edu), Phone: 858-964-5135